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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Complete if Known

Application Number	10/661,100
Filing Date	September 12, 2003
First Named Inventor	Sandhu, Gurtej
Group Art Unit	2891
Examiner Name	Zarneke, David

Sheet 1 of 1

Attorney Docket No: 303.869US1

US PATENT DOCUMENTS

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Filing Date If Appropriate
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OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
DAZ		CHEN, Z. Y., et al., "Optical constants of tetrahedral amorphous carbon films in the infrared region and at a wavelength of 633 nm", <u>Journal of Applied Physics</u> , 87(9), (May 1, 2000), 4268-4273	
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EXAMINER

/David Zarneke/

DATE CONSIDERED

06/08/2006

Substitute Disclosure Statement Form (PTO-1449)

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